

Title: SEMICONDUCTOR LASER DEVICE AND METHOD OF
MANUFACTURING THE SAME
Inventor's Name: MIYACHI et al
Application No.: New Application
Docket No.: 107156-00217

FIG.1 A

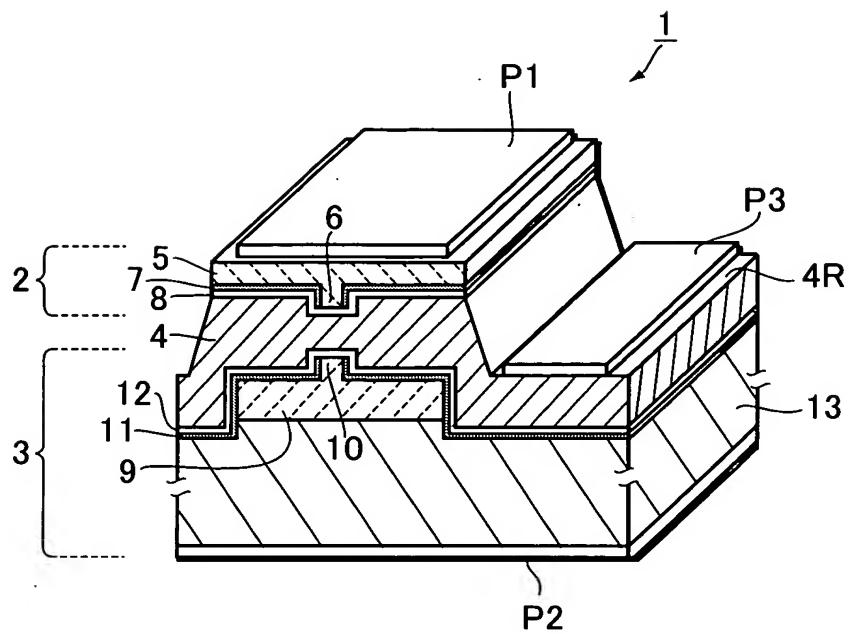
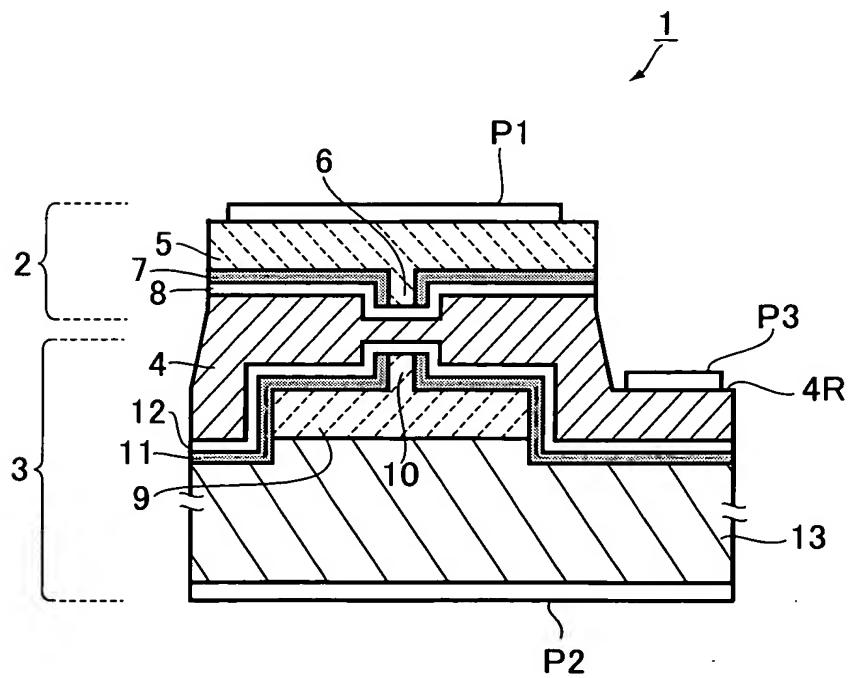


FIG.1 B



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FIG.2 A

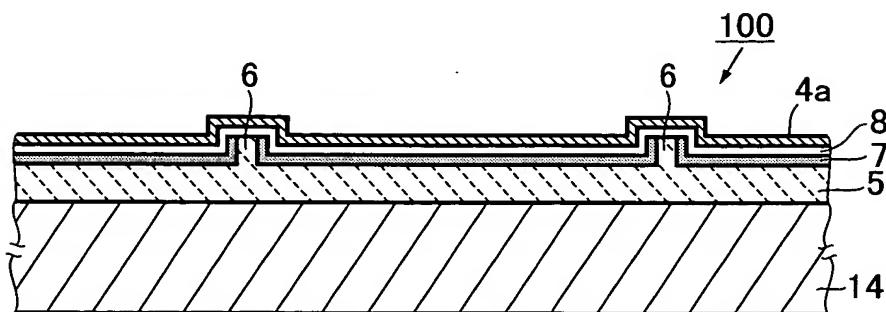


FIG.2 B

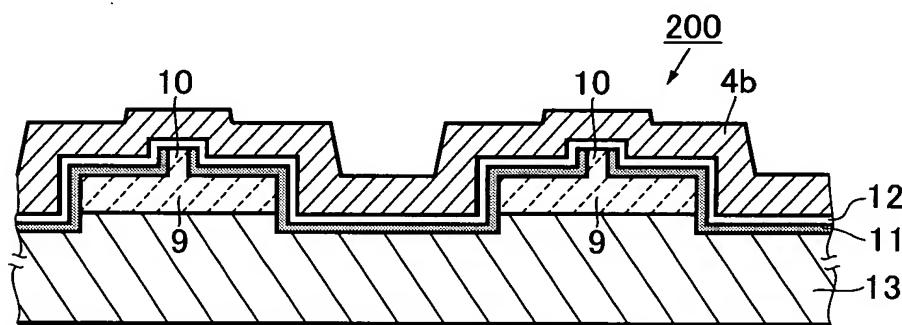


FIG.2 C

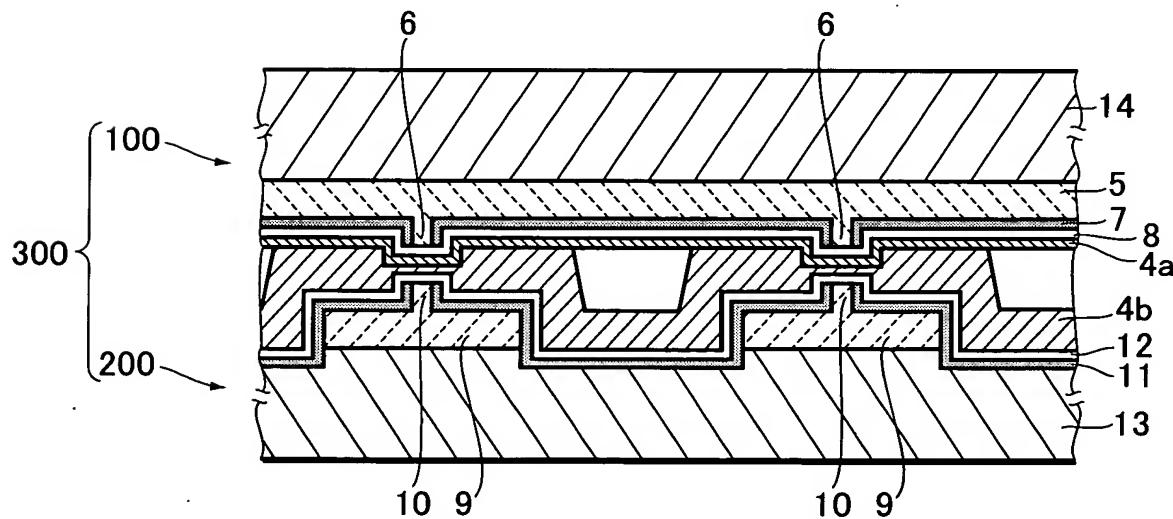


FIG.3 A

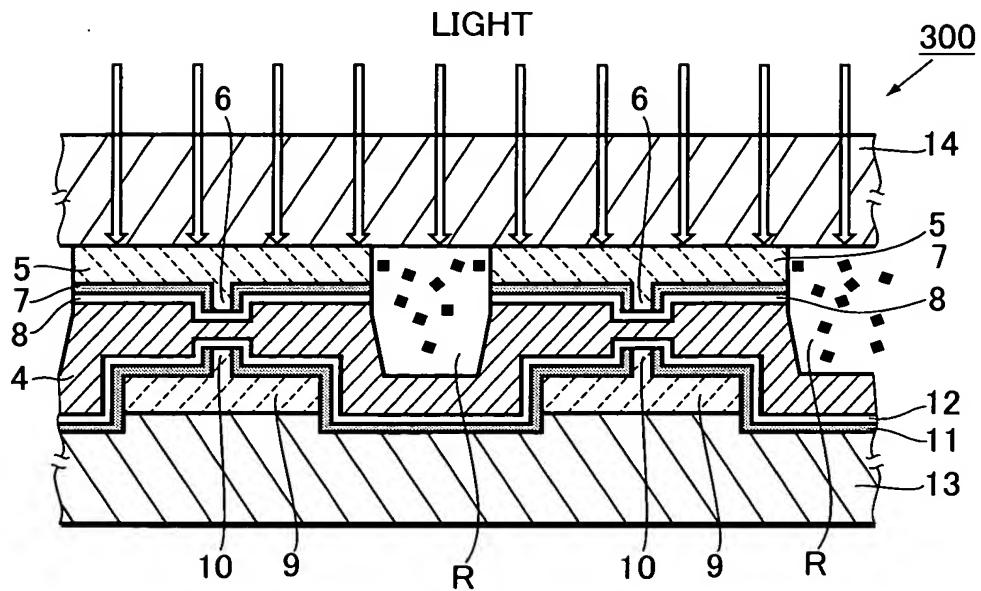


FIG.3 B

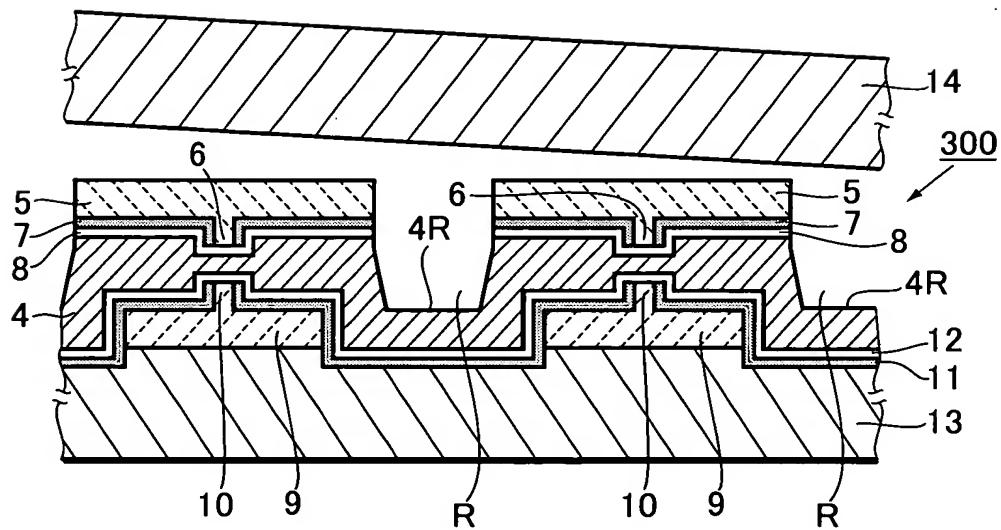


FIG.4 A

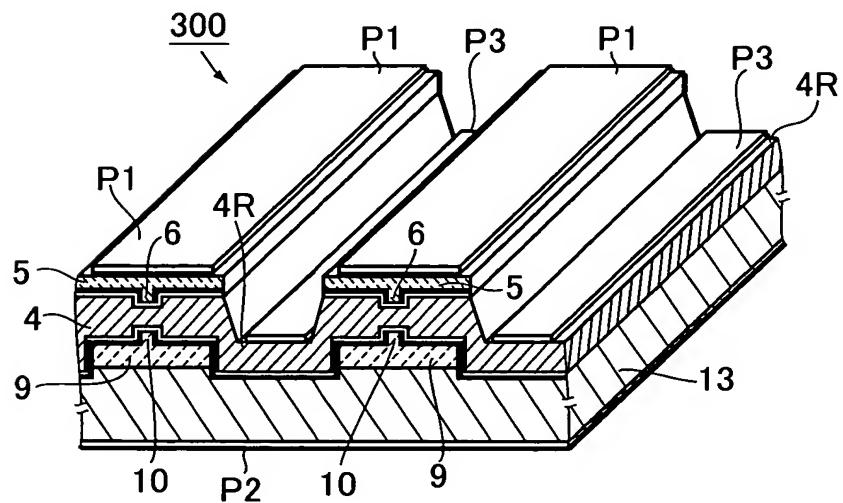


FIG.4 B

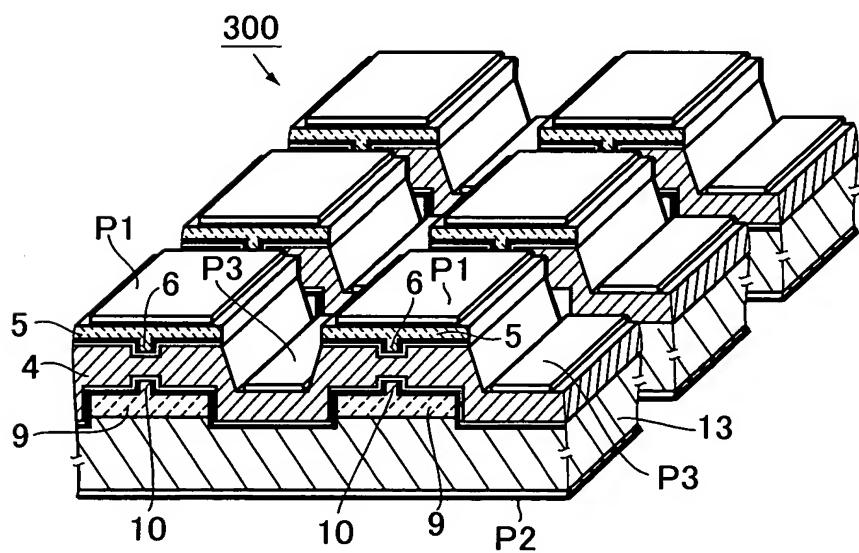
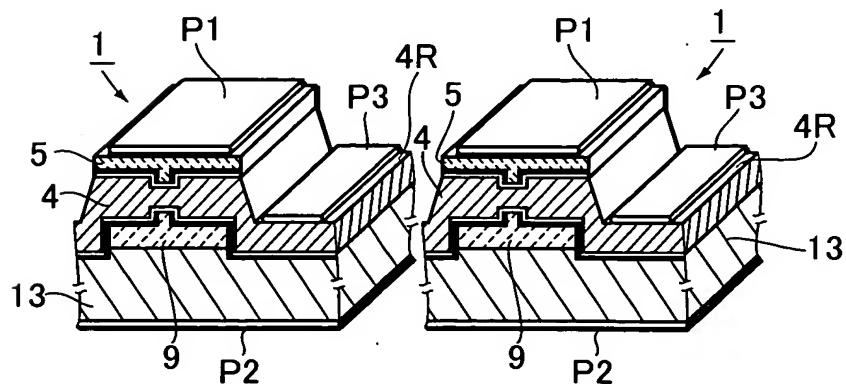
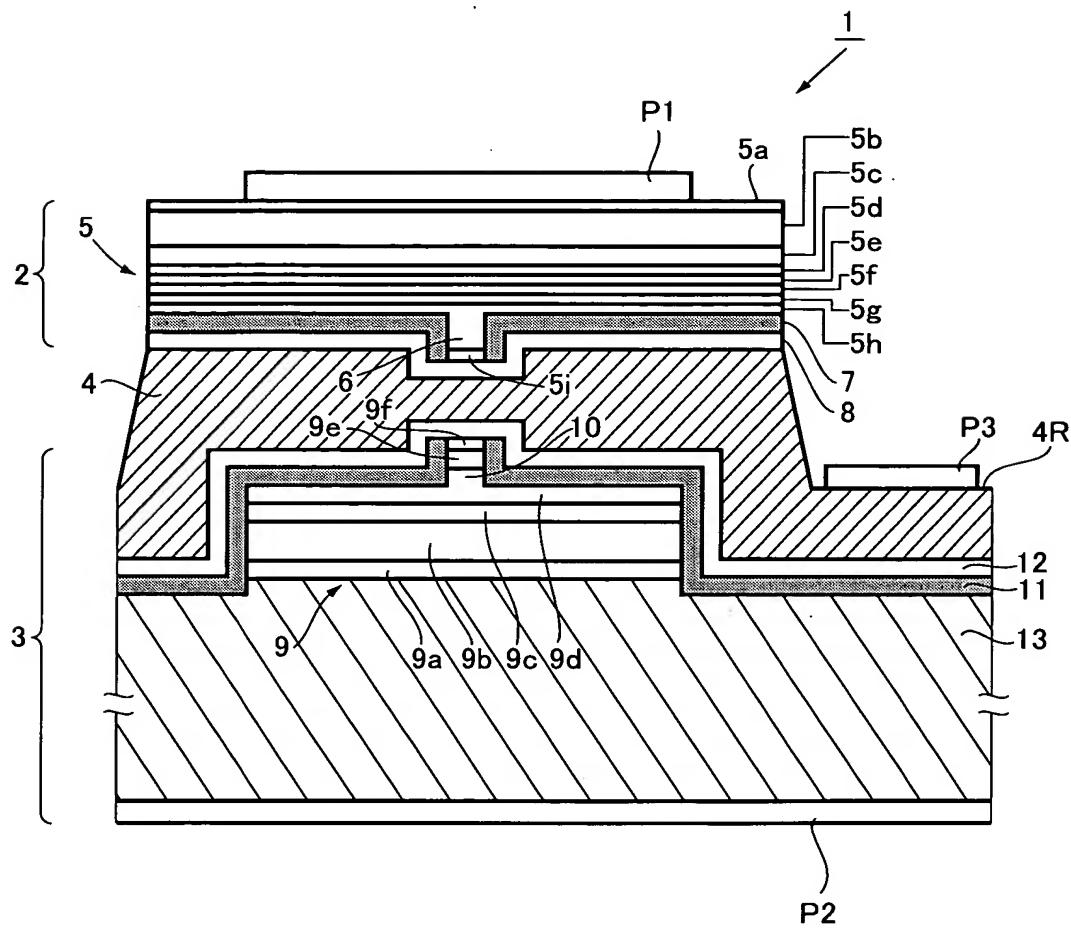


FIG.4 C



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FIG.5



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FIG.6 A

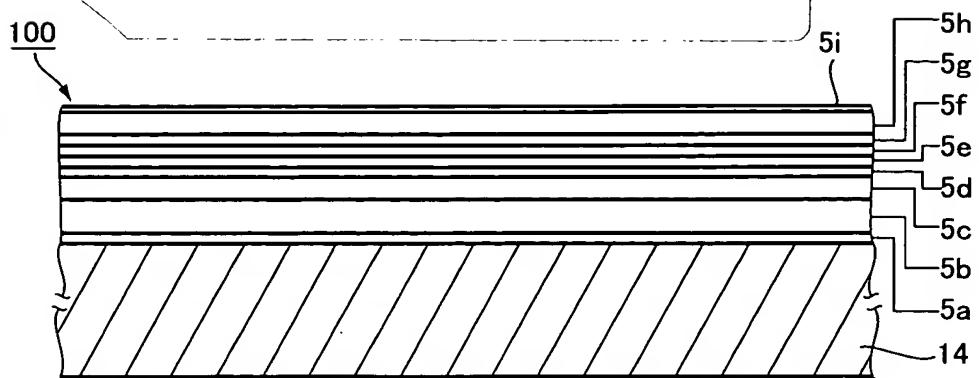


FIG.6 B

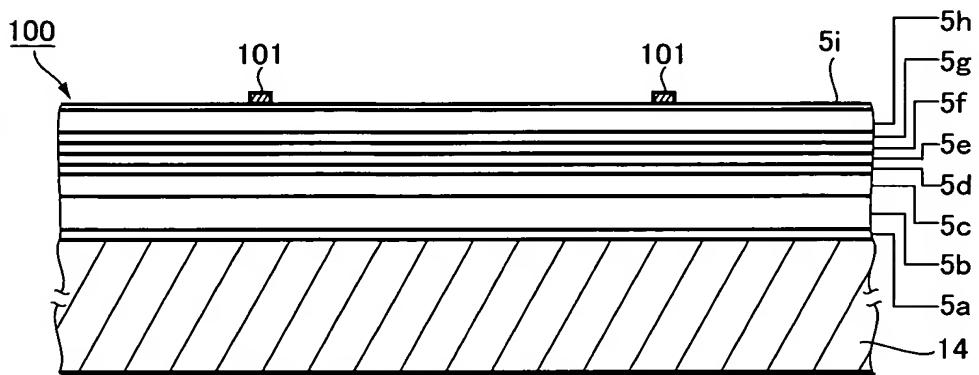


FIG.6 C

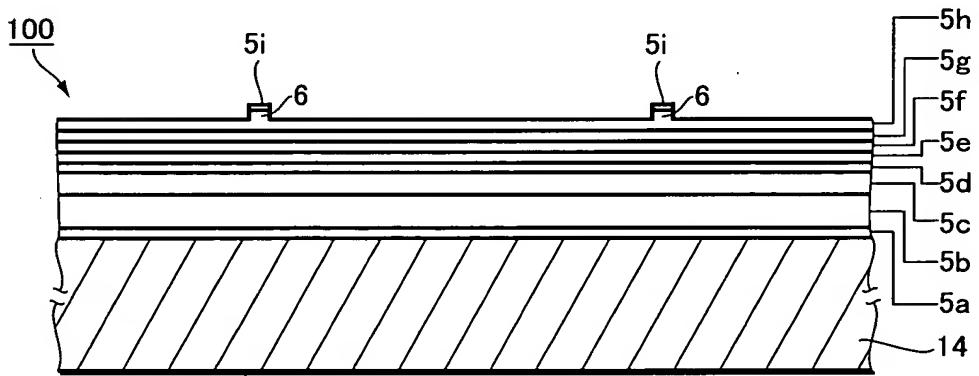
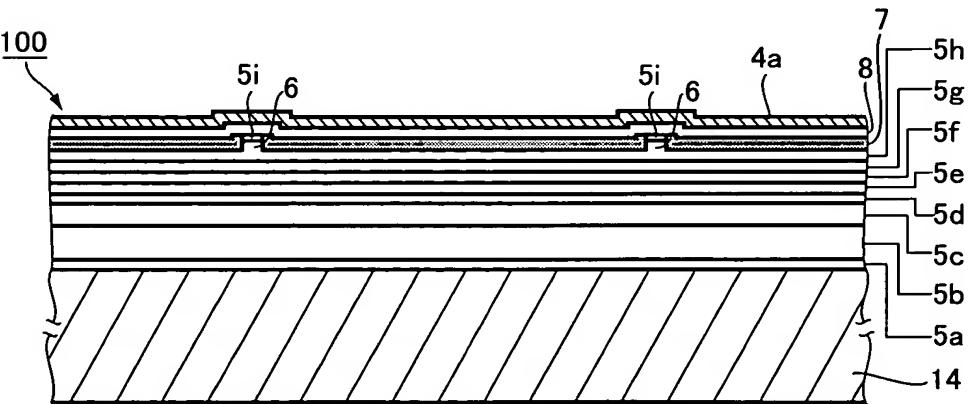


FIG.6 D



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FIG.7 A

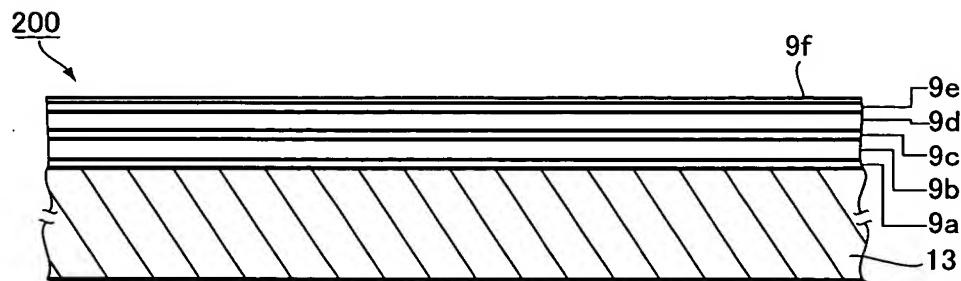


FIG.7 B

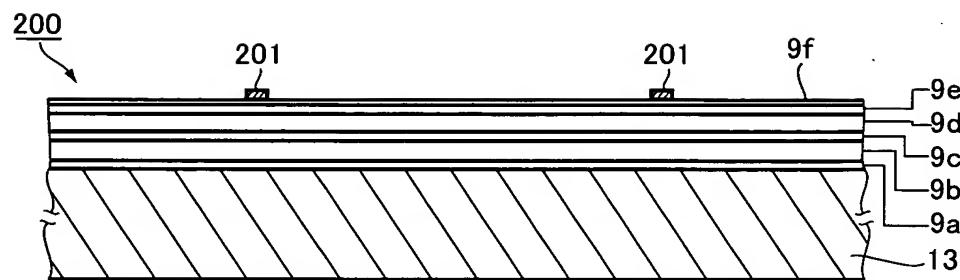


FIG.7 C

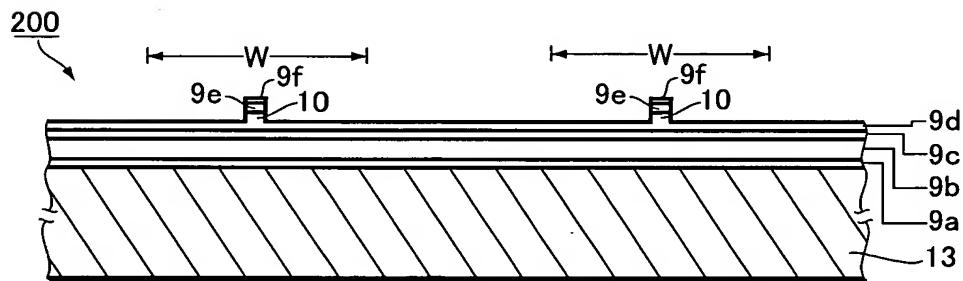
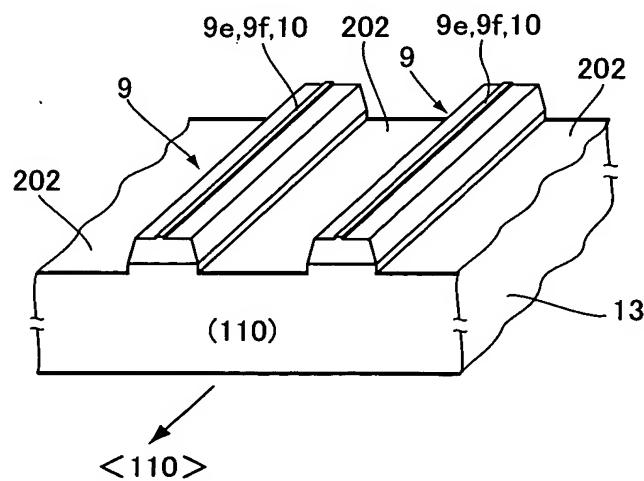


FIG.7 D



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FIG.8 A

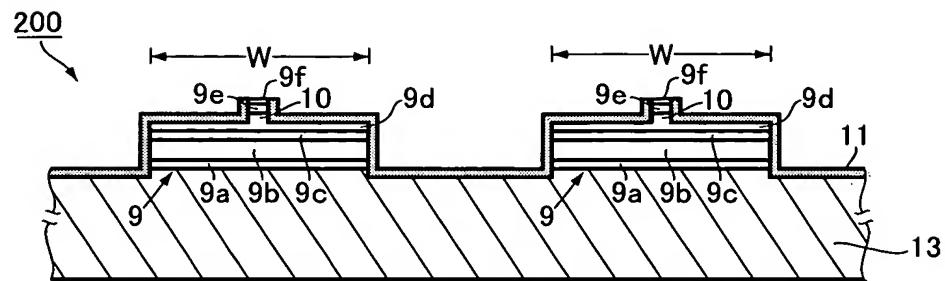
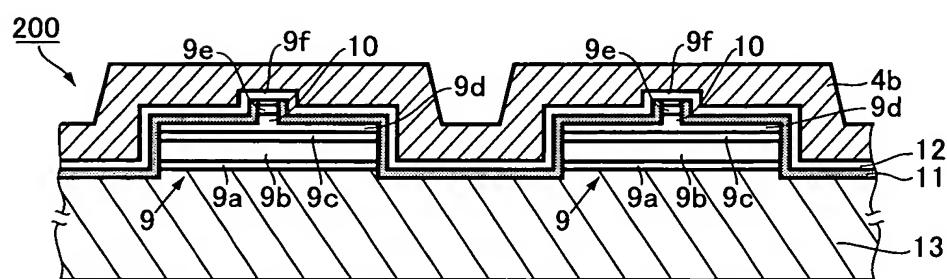
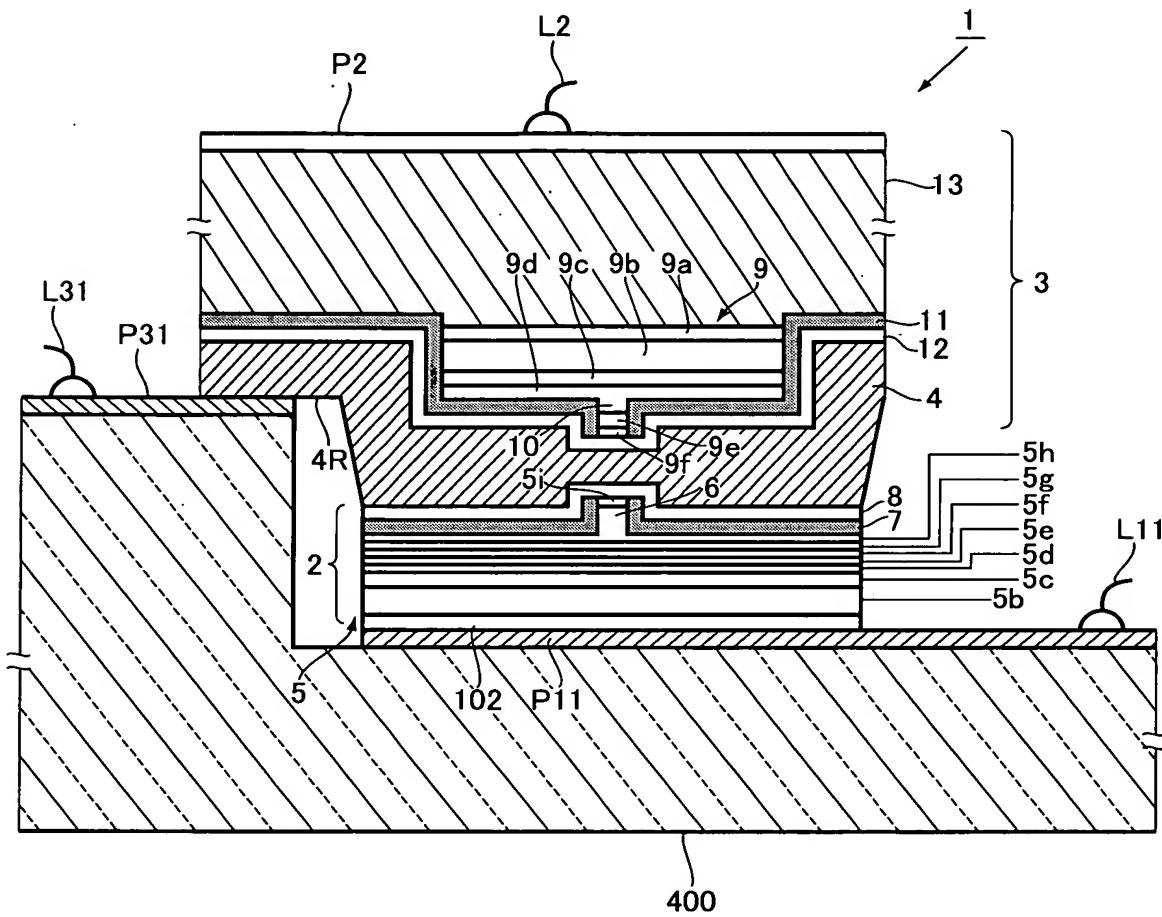


FIG.8 B



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FIG.9



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FIG.10 A

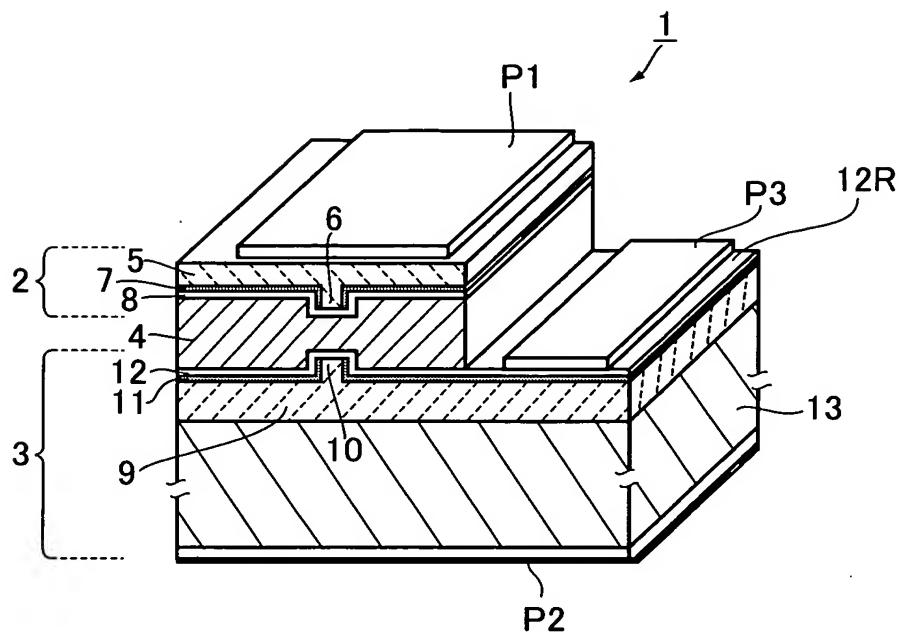
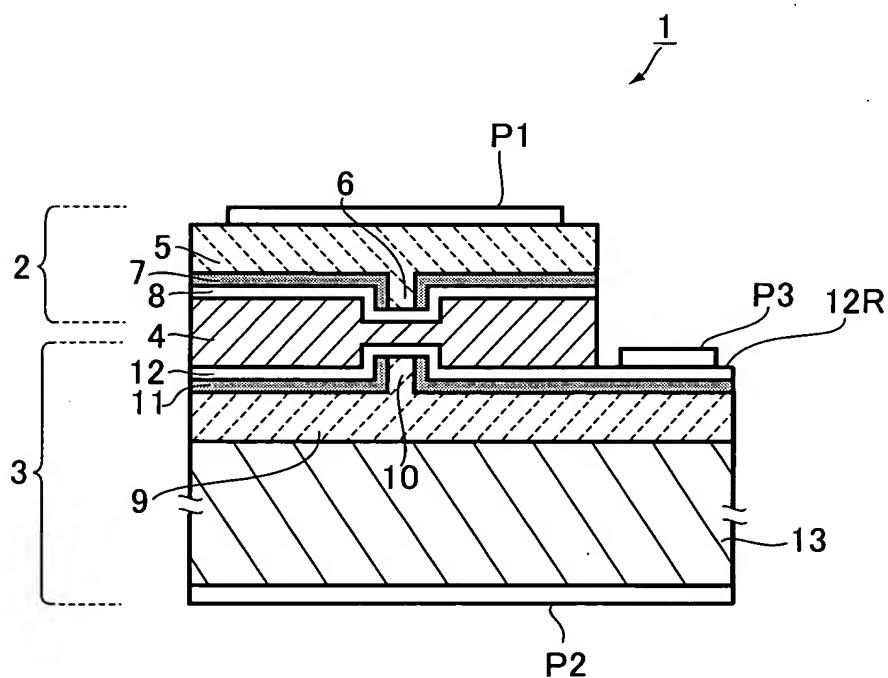


FIG.10 B



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FIG.11 A

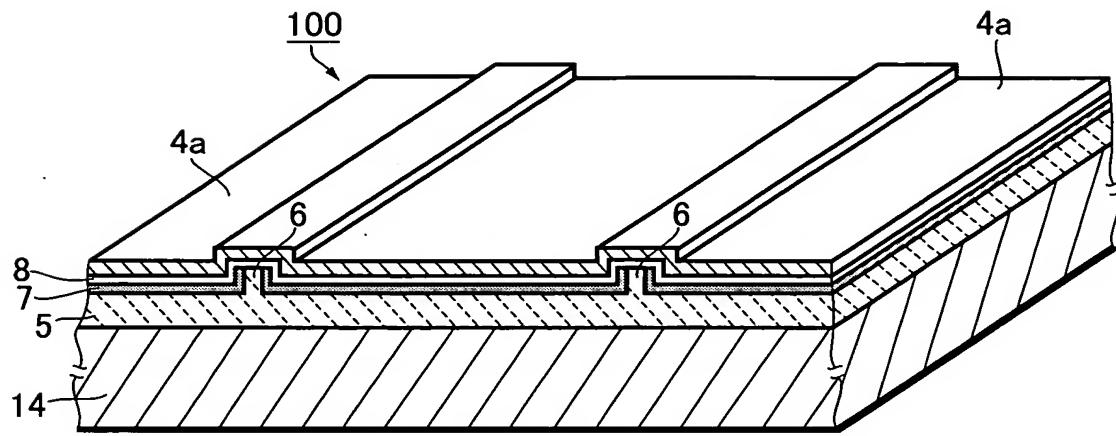
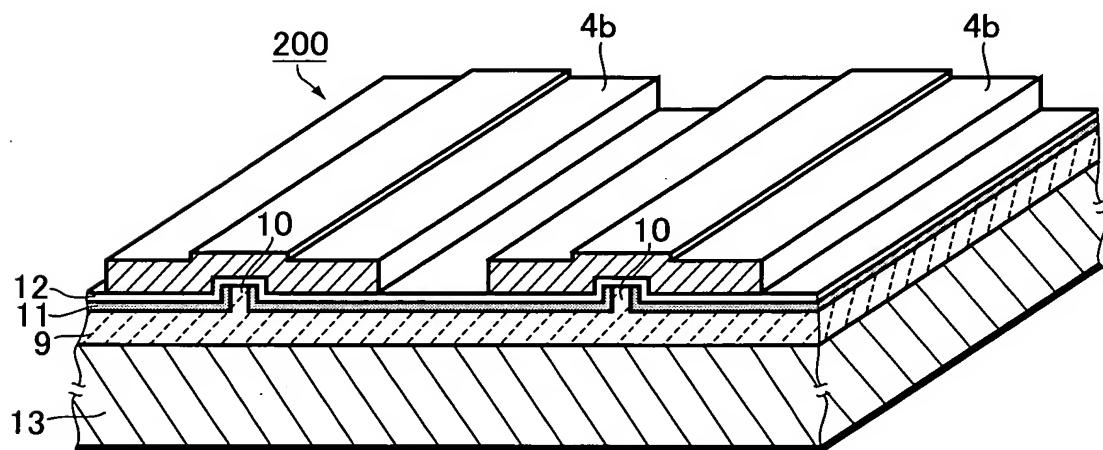


FIG.11 B



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FIG.12 A

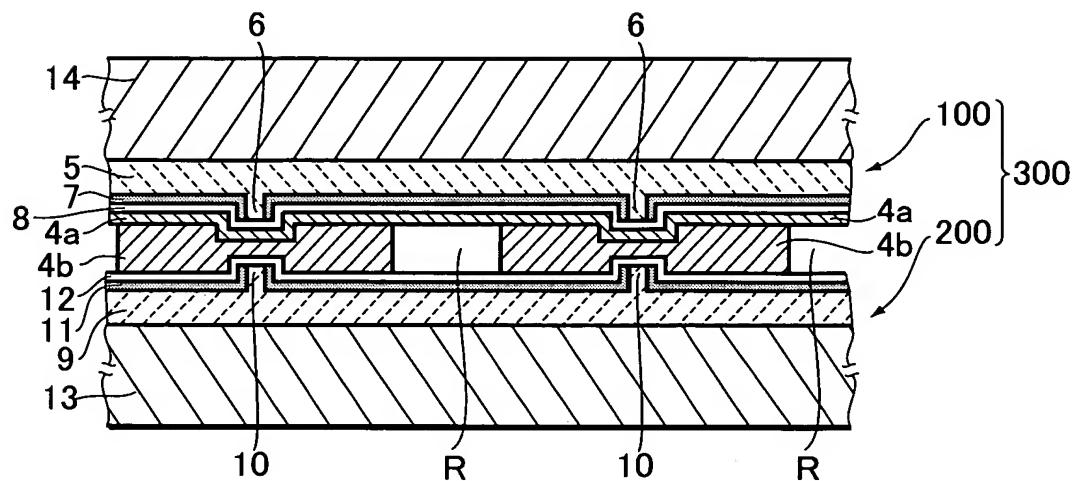


FIG.12 B

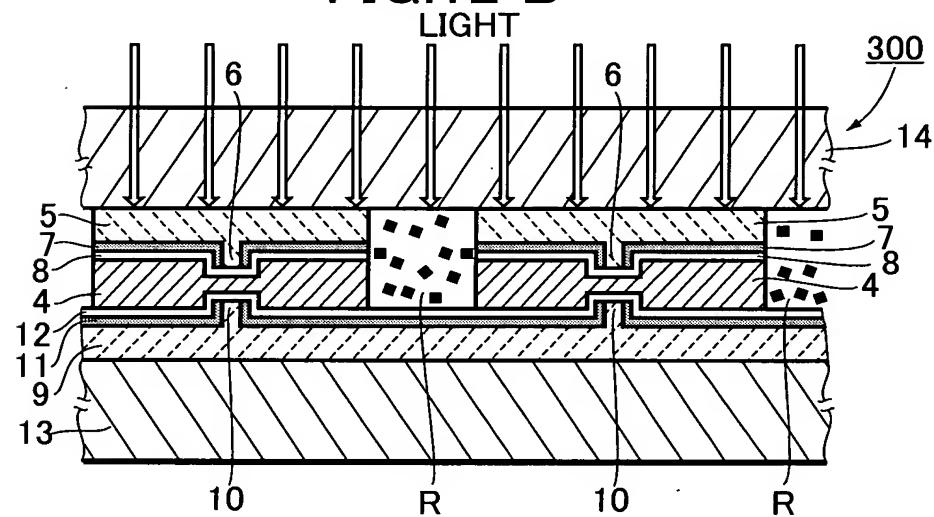
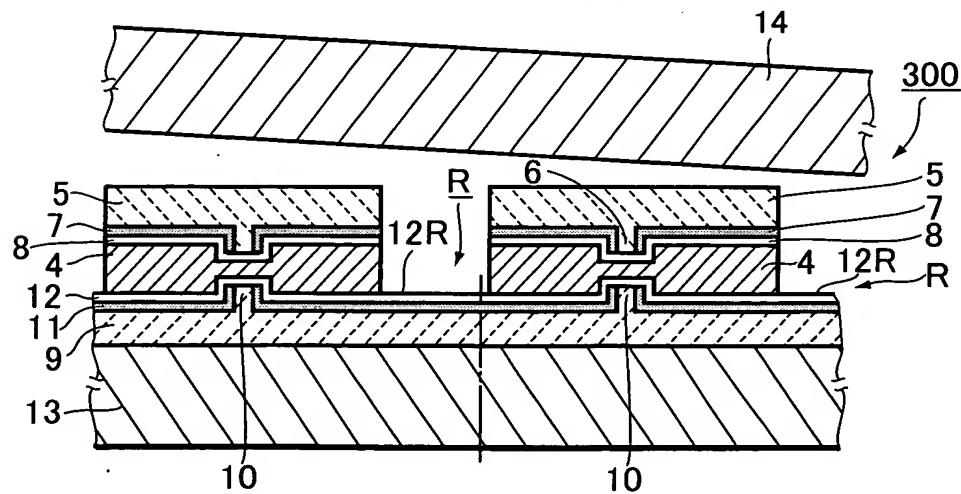


FIG.12 C



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FIG.13

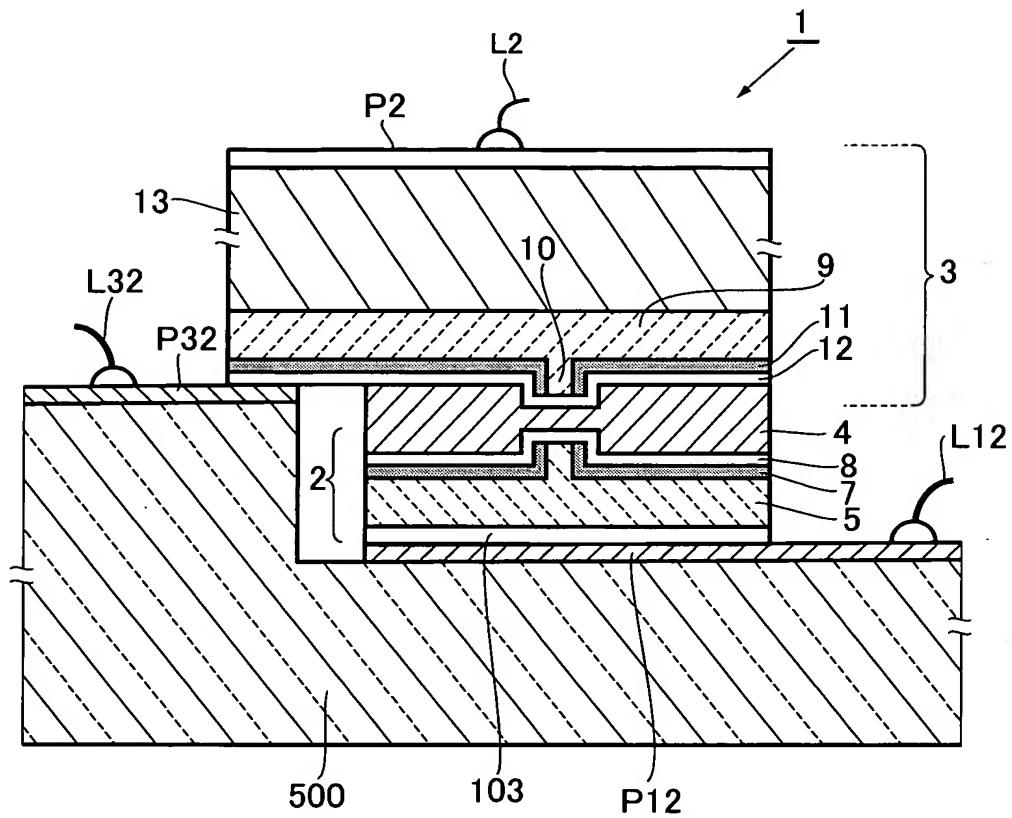


FIG.14 A

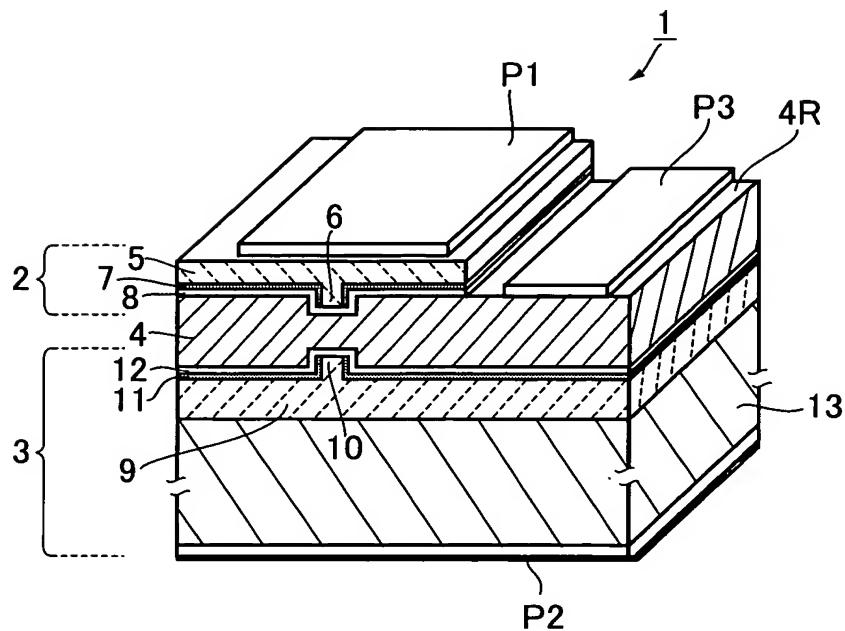
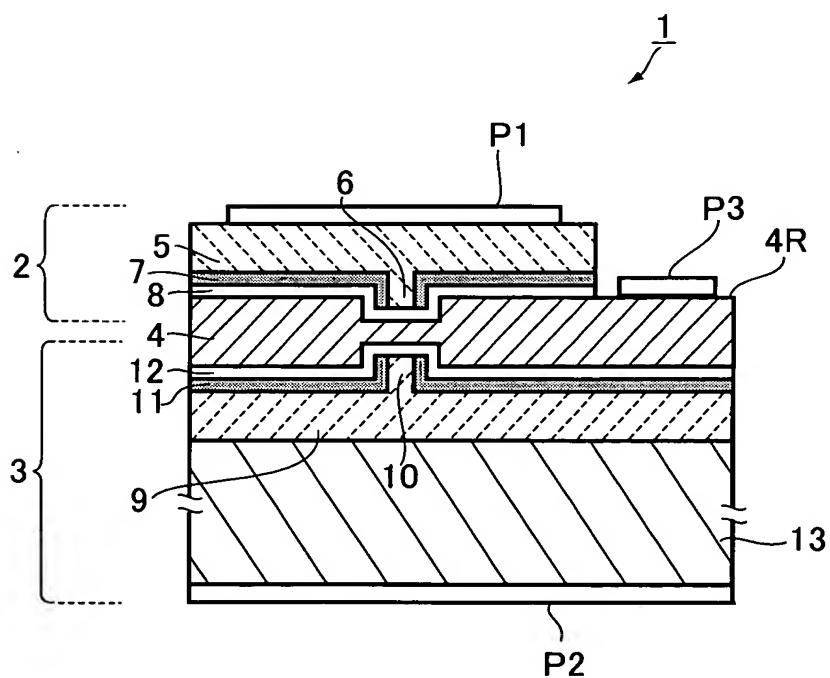


FIG.14 B



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FIG.15 A

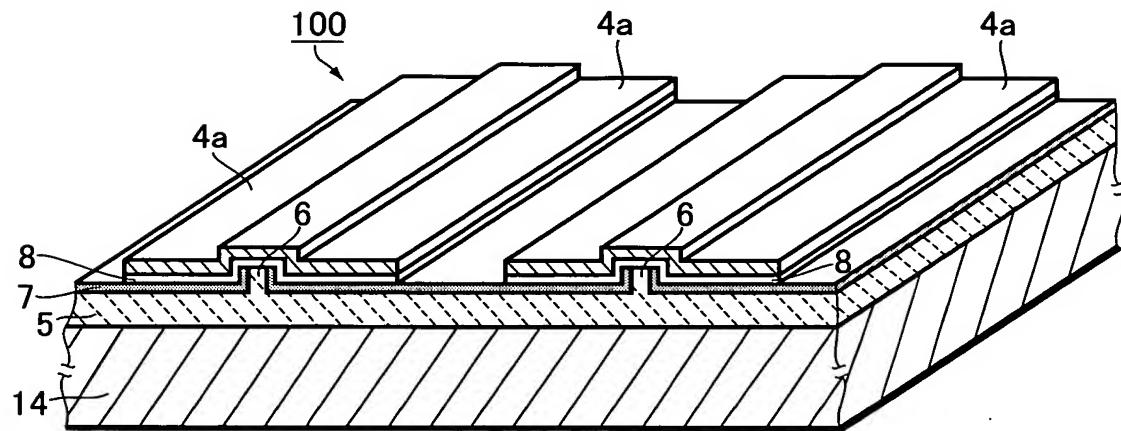


FIG.15 B

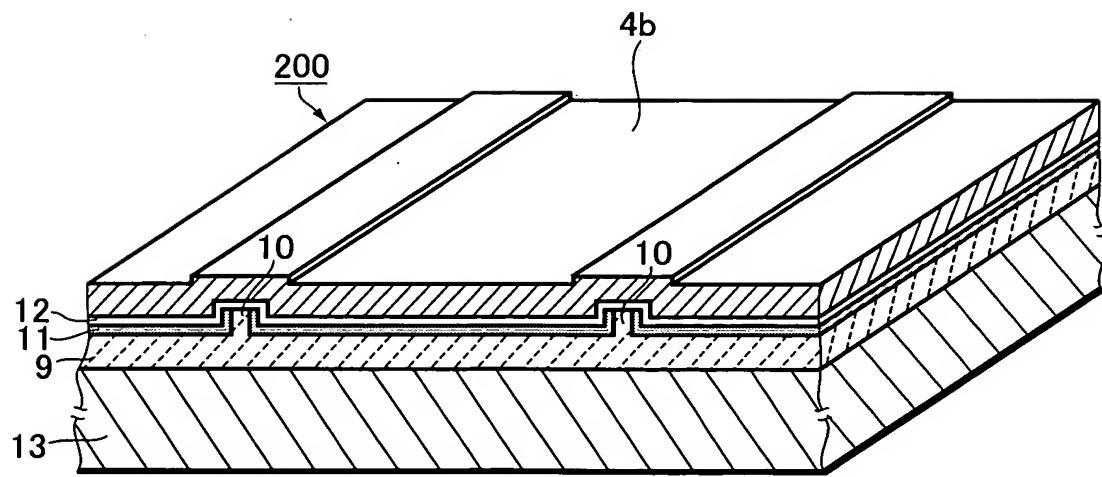


FIG.16 A

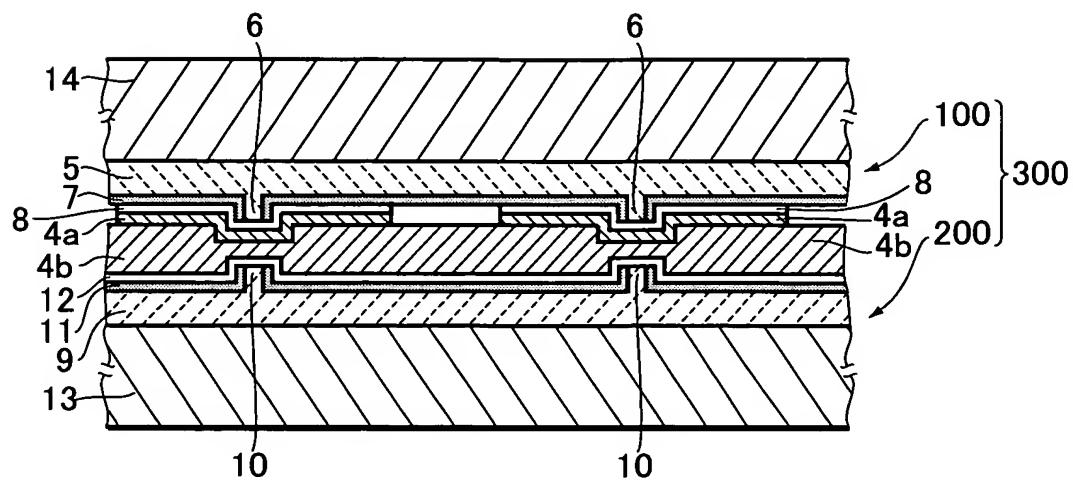


FIG.16 B

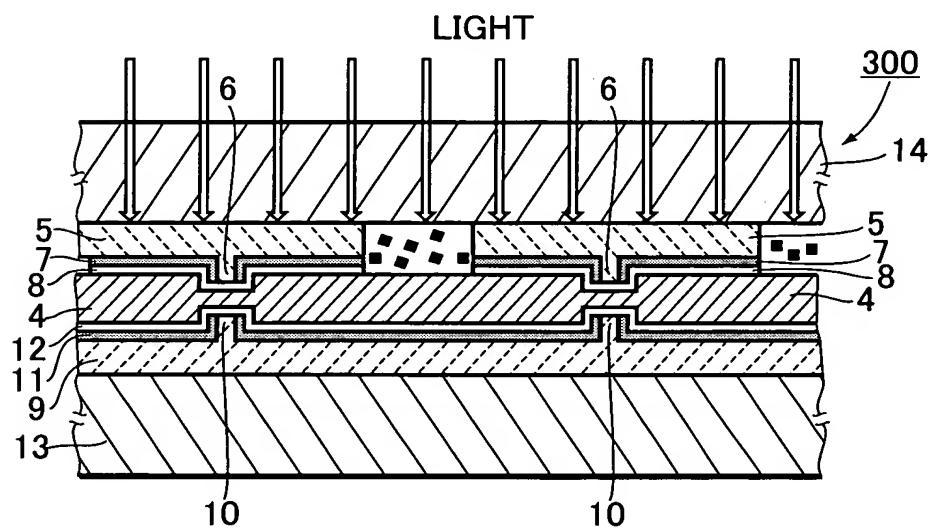
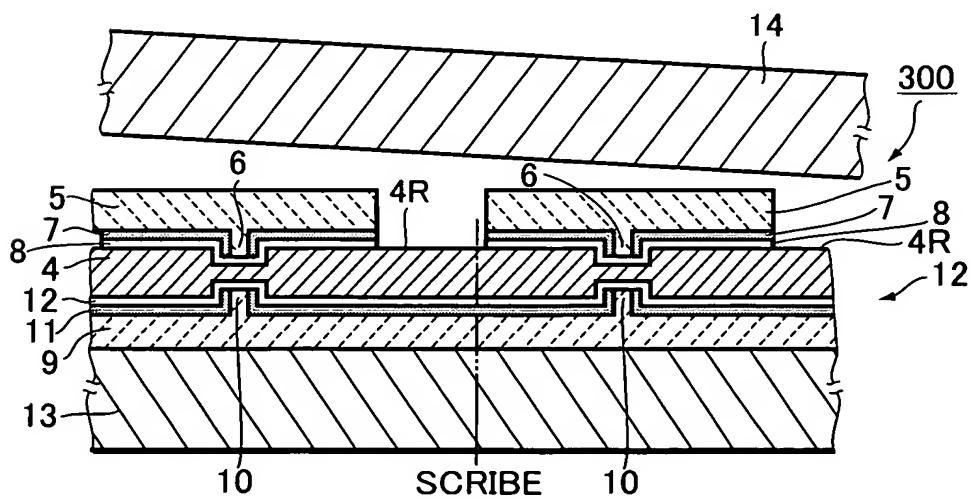
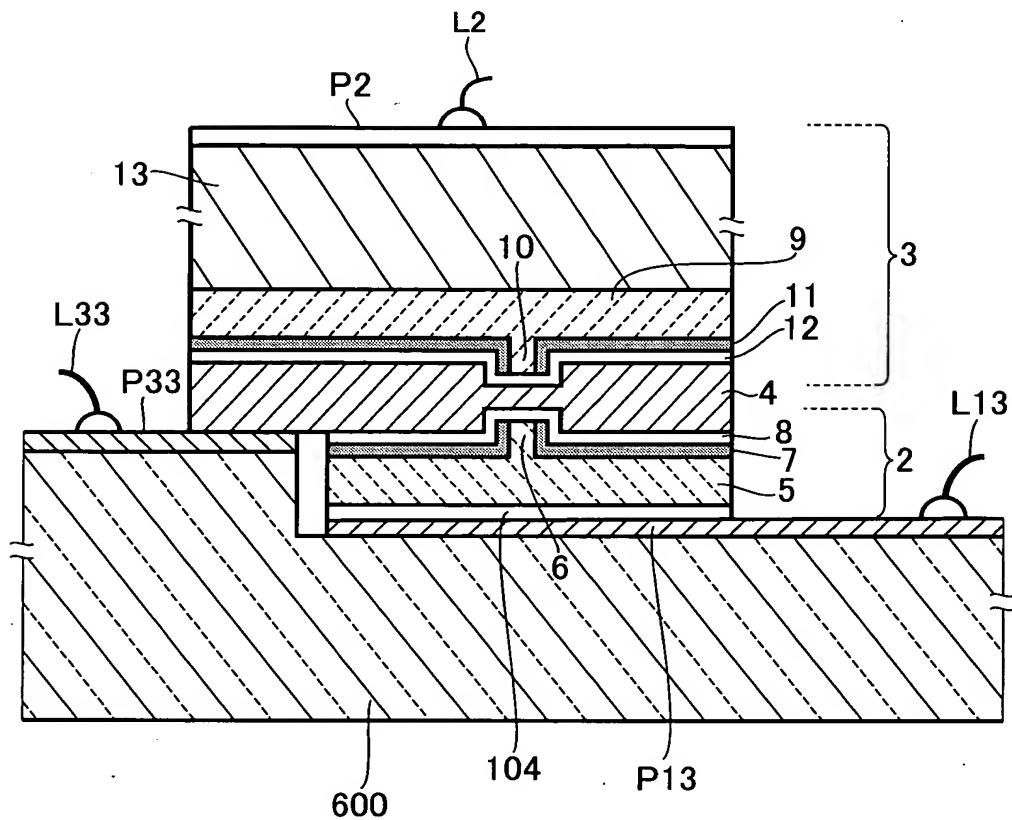


FIG.16 C



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FIG.17



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FIG.18

